

## Three-dimensional numerical simulation of discharge and flow related to airflow control using plasma actuator

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### ● Abstract

Plasma actuator has attracted attention as a fluid control device using dielectric barrier discharge. In the experimental study, it has been pointed out that the discharge has a spanwise distribution of the electrode and has a three-dimensional structure. The three-dimensional structure affects the induced flow distribution of the plasma actuator. In this study, we perform the three-dimensional numerical calculation of discharge and flow for verification of airflow control effect of plasma actuator.

### ● Reasons and benefits of using JAXA Supercomputer System

In the calculation of the discharge phenomenon, it is necessary to solve Poisson's equation at every time step, and it is solved using a convergence calculation, which calculation cost is high. In addition, since three-dimensional calculations are performed in this research, the required memory capacity is so large, and a supercomputer is necessary.

### ● Achievements of the Year

In this year, three-dimensional numerical simulation of the discharge process were performed toward coupling simulation of discharge process and fluid flows controlled by DBD plasma actuators. In order to investigate the discharge process of a plasma actuator under practical conditions, a model simulating the effect of external ultraviolet irradiation is developed and the discharge simulations were performed. The model takes into account the desorbed electron flux from the dielectric surface due to ultraviolet irradiation. It is found that the ultraviolet irradiation model suppresses the branching of the discharge structure in streamer-type discharges. This result suggests that the spanwise inhomogeneity of the discharge, which hinders the improvement of the airflow generation efficiency, can be mitigated in the ultraviolet irradiation environment brought about by the sun. We will investigate the induced flow characteristics of the plasma actuator in a more realistic environment by

simultaneously assuming a low-pressure environment at a high altitude in addition to the ultraviolet irradiation as future works.

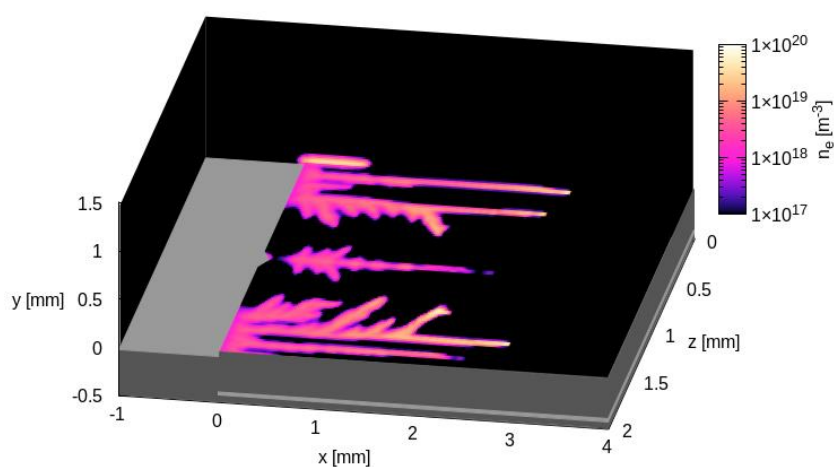


Fig. 1: Electron number density distribution during discharge propagation without UV irradiation model.

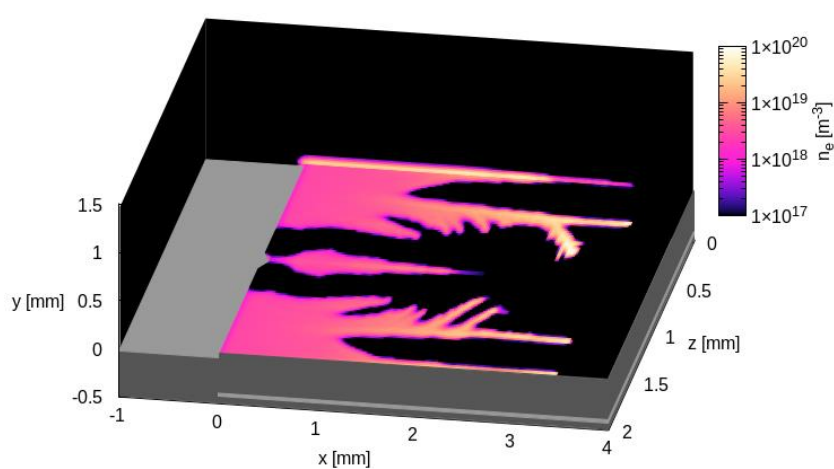


Fig. 2: Electron number density distribution during discharge propagation with UV irradiation model.

## ● Publications

N/A

## ● Usage of JSS

### ● Computational Information

Process Parallelization Methods	MPI
Thread Parallelization Methods	N/A
Number of Processes	36 - 720
Elapsed Time per Case	9 Hour(s)

### ● JSS3 Resources Used

Fraction of Usage in Total Resources\*1(%): 0.01

Details

Computational Resources		
System Name	CPU Resources Used (core x hours)	Fraction of Usage*2(%)
TOKI-SORA	0.00	0.00
TOKI-ST	61,912.32	0.06
TOKI-GP	0.00	0.00
TOKI-XM	0.00	0.00
TOKI-LM	0.00	0.00
TOKI-TST	0.00	0.00
TOKI-TGP	0.00	0.00
TOKI-TLM	0.00	0.00

File System Resources		
File System Name	Storage Assigned (GiB)	Fraction of Usage* <sup>2</sup> (%)
/home	585.00	0.39
/data and /data2	46,930.00	0.22
/ssd	5,020.00	0.27

Archiver Resources		
Archiver Name	Storage Used (TiB)	Fraction of Usage* <sup>2</sup> (%)
J-SPACE	3.47	0.01

\*<sup>1</sup>: Fraction of Usage in Total Resources: Weighted average of three resource types (Computing, File System, and Archiver).

\*<sup>2</sup>: Fraction of Usage : Percentage of usage relative to each resource used in one year.

#### ● ISV Software Licenses Used

ISV Software Licenses Resources		
	ISV Software Licenses Used (Hours)	Fraction of Usage* <sup>2</sup> (%)
ISV Software Licenses (Total)	0.00	0.00

\*<sup>2</sup>: Fraction of Usage : Percentage of usage relative to each resource used in one year.